

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:	REED et al.)	
)	Examiner: Diana J. Liao
Application No.:	10/786,621)	
)	Group Art Unit: 1793
Filed:	February 25, 2004)	
)	Confirmation No.: 2048
Docket No.	CPM03008 (3600-421-01))	

For: PHASE FORMATION OF OXYGEN REDUCED VALVE METAL OXIDES
AND GRANULATION METHODS

SUPPLEMENTAL
DECLARATION UNDER 37 C.F.R. § 1.132

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

I, Sridhar Venigalla, do declare and state as follows:

(1) I am currently employed with Cabot Corporation. My position at Cabot Corporation and my educational background are described in the Declaration filed on December 18, 2008, for the above-identified application. I am one of the named inventors of this application.

(2) I am familiar with the Office Action dated April 14, 2009, received in the examination of U.S. Patent Application No. 10/786,621. I am also familiar with Kimmel et al., the cited reference relied upon by the Examiner.

(3) In the Declaration, I described tests for flow rates of six samples of niobium suboxide powders, prepared by the method used in Example 1 of Kimmel et al., wherein niobium metal was used as the getter material and the starting niobium oxide was Nb₂O₅. I confirm that the measurement standard used for the flow measurements of these six samples was ASTM B 213.

(4) I hereby declare that all statement made herein of my own knowledge are true and

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Supplemental Declaration under 37 C.F.R. §1.132

that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

5 / 13 / 2009
Date

Sridhar Venigalla
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